



*Image AF/1765*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

TAKENO

Attorney Docket No: 107242-00024

Application No. 09/926,202

Art Unit: 1765

Filed: September 24, 2001

Examiner: M. Anderson

For: MANUFACTURING PROCESS FOR SILICON EPITAXIAL WAFER

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
Washington, D.C. 20231

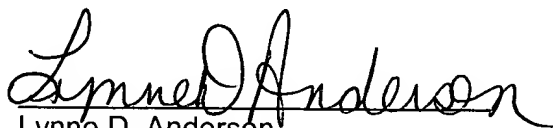
Date: March 8, 2004

Sir:

Applicant(s) petition for an extension of time for one month for response to the Notice of Appeal dated December 8, 2003 from February 8, 2004 to March 8, 2004.

Please find attached a check in the amount of \$110.00 to cover the fee for discussed above. The Commissioner is hereby authorized to charge any fee deficiency or credit any overpayment associated with this communication to Deposit Account No. 01-2300, referring to Attorney Docket number 107242-00024.

Respectfully submitted,

  
Lynne D. Anderson  
Registration No. 46,412

Customer No. 004372  
ARENT FOX PLLC  
1050 Connecticut Avenue, N.W.,  
Suite 400  
Washington, D.C. 20036-5339  
Tel: (202) 857-6000  
Fax: (202) 638-4810